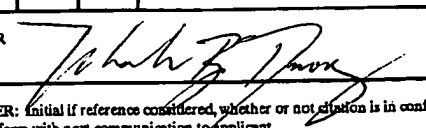


Form PTO-1449		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY. DOCKET NO. MI22-2395		Priority SERIAL NO. 10/208,154	
LIST OF ART CITED BY APPLICANT (Use several sheets if necessary)				APPLICANT Jerome M. Eldridge		Priority FILING DATE July 29, 2002	
				Priority GROUP 2822			
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*Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
KED ↓	AA	5,350,738	9/27/94	Hase et al			
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	AL						
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KED ↓	AN	John Baliga, "New Materials Enhance Memory Performance", Semiconductor International, November 1999, pgs. 1-8.					
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	AV	Richard A. Swalin, "Thermodynamics of Solids", Second Edition, Chapter 5, John Wiley & Sons, 1972, pgs. 112-115.					
EXAMINER <i>John B. Phony</i>				DATE CONSIDERED 8/22/2004			
*EXAMINER: initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.							

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				FILING DATE Filed Herewith	GROUP Unknown	
U.S. PATENT DOCUMENTS						
*Examiner Initial	Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
KBD	AA 09/651,380		Eldridge (as filed and amended 3/28/02)			8/29/00
	AB					
	AC					
	AD					
	AE					
	AF					
	AG					
	AH					
	AI					
	AJ					
	AK					
	AL					
FOREIGN PATENT DOCUMENTS						
	Document Number	Date	Country	Class	Subclass	Translation Yes No
	AM					
	AN					
	AO					
	AP					
	AQ					
OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)						
	AR					
	AS					
	AT					
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